

Figure 1. After a very short nucleation delay, the TMA and H_2S/Ar -plasma ALD process is linear. The highest growth rate was at $100^{\circ}C$.

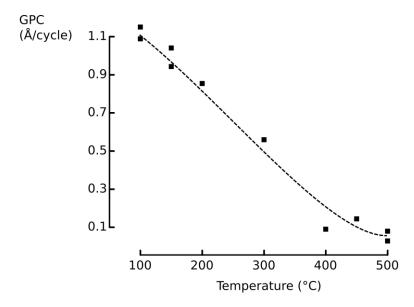


Figure 2. The growth per cycle (GPC) of the TMA and H_2S/Ar -plasma processes decreases for higher temperatures. The dashed line is a guide to the eye.

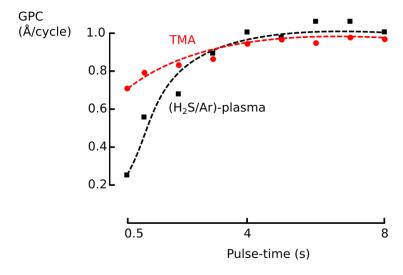


Figure 3. The PE-ALD process based on TMA and H_2S/Ar -plasma saturates after approximately 4s pulse time for each half cycle. Dashed lines are a guide to the eye.